



Serial No. 10/780,867  
OKI.390C  
Amendment dated August 29, 2005

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of

Kazuya Hizawa

Group Art Unit: 2822

Serial No.: 10/780,867

Examiner: C. Novacek

Filed: February 19, 2004

Confirm No.: 1983

For: A METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE HAVING A  
METALLIC SILICIDE LAYER

**AMENDMENT**

U.S. Patent and Trademark Office  
Customer Window, **Mail Stop Amendment**  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Date: August 29, 2005

Sir:

In response to the Office Action dated May 18, 2005, the period for response having been extended one (1) month to September 18, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.